RESPONSE UNDER 37 C.F.R. § 1.116 CENTRAL FAX CENTER

EXPEDITING PROCEDURE EXAMINING GROUP 2800

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FACSIMILE COVER SHEET

To Examiner: Steven Ho Yin Loke

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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant:

Lehmann, et al.

Docket No.:

00P0113 US

Serial No.:

09/751,474

Art Unit:

2811

Date Filed:

December 28, 2000

TITLE:

Area Efficient Stacking Of Antifuses In Semiconductor Device

CERTIFICATION OF FACSIMILE TRANSMISSION

I hereby certify that the following papers are being transmitted by facsimile to Mail Stop AF at the U.S. Patent and Trademark Office at (571) 273-8300 on February 10, 2006:

- Certification of Facsimile Transmission (1 page)
- Amendment (13 pages)

Respectfully submitted,

Legal Assistant

Confirmation Respectfully Requested

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For:

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Mail Stop Amendment AF Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

AMENDMENT UNDER 37 C.F.R. § 1.116

Dear Sir:

The following amendments and remarks are presented in response to the Examiner's Final Office Action mailed December 14, 2005. Please amend the above-referenced application as follows.